



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of: SINGH et al.

RECEIVED

Application No.: 10/082,010

Examiner:

MAR 09 2004

Date Filed: February 22, 2002

Group: 2812

For: SLURRY AND METHOD FOR CHEMICAL MECHANICAL POLISHING  
OF METAL STRUCTURES INCLUDING REFRACTORY METAL  
BASED BARRIER LAYERS

CERTIFICATE UNDER 37 CFR 1.8(a)

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on March 1, 2004.

Neil R. Jetter

Reg. No. 46,803

PETITION FOR RETROACTIVE EXTENSION OF TIME

Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is a Petition for Retroactive Extension of Time pursuant to 37 CFR § 1.136. The Commissioner is hereby authorized to charge the fee in the amount of \$55.00 for a one (1) month extension of time pursuant to 37 CFR § 1.17(a)(1), as well as any underpayment to Deposit Account No. 50-0951. A duplicate copy of this communication is enclosed.

Respectfully submitted,

Date: 3/1/04

Neil R. Jetter, Reg. No. 46,803  
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Docket No. 5853-224

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